

033082M341

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Itaru KANNO, et al.

CONFIRMATION NO.: 1445

U.S. Serial No.: 10/591,474

Group Art Unit: 2853

Filed: September 1, 2006

Examiner: Benjamin Lee Osterhout

For: TWO-FILLED NOZZLE FOR CLEANING SUBSTRATE AND SUBSTRATE
CLEANING APPARATUS

FOURTH INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

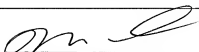
Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in the Japanese Office Action issued on July 7, 2009. A copy of the documents cited therein are enclosed.

The fee of \$180.00 is believed to be due with this filing. If for any reason, other fees are required relative to this filing, the Commissioner is authorized to charge the fees to SGR Deposit Account No. 02-4300.

It is respectfully requested that the cited documents be considered by the Examiner, that they be made officially of record therein, and that the documents be listed on the face of any patent which may issue from this application.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By:


Michael A. Makuch, Reg. No. 32,263
1130 Connecticut Avenue, Suite 1130
Washington, D.C. 20036
Telephone: (202) 263-4300
Fax: (202) 263-4329

September 17, 2009